

FORM PTO-1390 (Modified) (REV 10-95)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE ATTORNEY'S DOCKET NUMBER <b>2003JP314</b>	
<b>TRANSMITTAL LETTER TO THE UNITED STATES</b> <b>DESIGNATED/ELECTED OFFICE (DO/EO/US)</b> <b>CONCERNING A FILING UNDER 35 U.S.C. 371</b>		U.S. APPLICATION NO. (IF KNOWN, SEE 37 CFR To Be Assigned <b>10/564997</b>	
INTERNATIONAL APPLICATION NO. <b>PCT/JP2004/007706</b>	INTERNATIONAL FILING DATE <b>June 3, 2004</b>	PRIORITY DATE CLAIMED <b>July 14, 2003</b>	
TITLE OF INVENTION <b>DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND          METHOD FOR FORMING PATTERNED RESIST FILM</b>			
APPLICANT(S) FOR DO/EO/US <b>Tatsuro NAGAHARA, Tadashi MUTOH, Masanobu HAYASHI</b>			
Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information:			
<ol style="list-style-type: none"> <li>1. <input checked="" type="checkbox"/> This is a <b>FIRST</b> submission of items concerning a filing under 35 U.S.C. 371.</li> <li>2. <input type="checkbox"/> This is a <b>SECOND</b> or <b>SUBSEQUENT</b> submission of items concerning a filing under 35 U.S.C. 371.</li> <li>3. <input type="checkbox"/> This is an express request to begin national examination procedures (35 U.S.C. 371(f)) at any time rather than delay examination until the expiration of the applicable time limit set in 35 U.S.C. 371(b) and PCT Articles 22 and 39(1).</li> <li>4. <input type="checkbox"/> A proper Demand for International Preliminary Examination was made by the 19th month from the earliest claimed priority date.</li> <li>5. <input checked="" type="checkbox"/> A copy of the International Application as filed (35 U.S.C. 371 (c) (2))           <ol style="list-style-type: none"> <li>a. <input type="checkbox"/> is transmitted herewith (required only if not transmitted by the International Bureau).</li> <li>b. <input checked="" type="checkbox"/> has been transmitted by the International Bureau.</li> <li>c. <input type="checkbox"/> is not required, as the application was filed in the United States Receiving Office (RO/US).</li> </ol> </li> <li>6. <input checked="" type="checkbox"/> A translation of the International Application into English (35 U.S.C. 371(c)(2)).</li> <li>7. <input checked="" type="checkbox"/> A copy of the International Search Report (PCT/ISA/210).</li> <li>8. <input type="checkbox"/> Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371 (c)(3))           <ol style="list-style-type: none"> <li>a. <input type="checkbox"/> are transmitted herewith (required only if not transmitted by the International Bureau).</li> <li>b. <input type="checkbox"/> have been transmitted by the International Bureau.</li> <li>c. <input type="checkbox"/> have not been made; however, the time limit for making such amendments has NOT expired.</li> <li>d. <input type="checkbox"/> have not been made and will not be made.</li> </ol> </li> <li>9. <input type="checkbox"/> A translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371(c)(3)).</li> <li>10. <input checked="" type="checkbox"/> An oath or declaration of the inventor(s) (35 U.S.C. 371 (c)(4)).</li> <li>11. <input type="checkbox"/> A copy of the International Preliminary Examination Report (PCT/IPEA/409).</li> <li>12. <input type="checkbox"/> A translation of the annexes to the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. 371 (c)(5)).</li> </ol>			
<b>Items 13 to 18 below concern document(s) or information included:</b>			
<ol style="list-style-type: none"> <li>13. <input type="checkbox"/> An Information Disclosure Statement under 37 CFR 1.97 and 1.98.</li> <li>14. <input type="checkbox"/> An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included.</li> <li>15. <input checked="" type="checkbox"/> A <b>FIRST</b> preliminary amendment.                              A <b>SECOND</b> or <b>SUBSEQUENT</b> preliminary amendment.</li> <li>16. <input type="checkbox"/> A substitute specification.</li> <li>17. <input type="checkbox"/> A change of power of attorney and/or address letter.</li> <li>18. <input checked="" type="checkbox"/> Certificate of Mailing by Express Mail   EV 689560067 US</li> <li>19. <input type="checkbox"/> Other items or information:</li> </ol>			
Form PCT/IB/301 Form PCT/IB/304 Form PCT/IB/306 Form PCT/IB/306 Form PCT/IB/306 Form PCT/IB/306 Form PCT/IB/308 WO 2005/006083 A1			

Page 2 of 2

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.  
To Be AssignedFiling Date  
January 13, 2006Examiner  
To Be AssignedGroup Art Unit  
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this Transmittal Letter (1 original and 1 copy) - 4 Pages

(Identify type of correspondence)

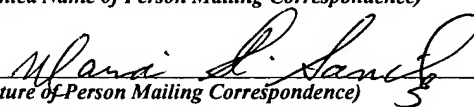
is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.20231-0001 on January 13, 2006  
(Date)MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

  
(Signature of Person Mailing Correspondence)EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.

<b>CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)</b>			Docket No.
Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI			2003JP314
Serial No. To Be Assigned	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: <b>DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM</b>			
<p>I hereby certify that this <u>Patent Application - 23 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.</p> <p>20231-0001 on <u>January 13, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u></u> (Signature of Person Mailing Correspondence)</p> <p><u>EV 689560067 US</u> ( "Express Mail" Mailing Label Number)</p>			
<p><b>Note: Each paper must have its own certificate of mailing.</b></p>			

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.  
To Be AssignedFiling Date  
January 13, 2006Examiner  
To Be AssignedGroup Art Unit  
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this Drawings - 1 Page


(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.

20231-0001 on January 13, 2006  
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

  
(Signature of Person Mailing Correspondence)EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.

10/564997

JP15 Rec'd PCT/PTO 13 JAN 2006

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**


Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.  
To Be AssignedFiling Date  
January 13, 2006Examiner  
To Be AssignedGroup Art Unit  
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this **International Search Report (Form PCT/ISA/210) for PCT/JP2004/007706 - 3 Pages**  
(Identify type of correspondence)is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.20231-0001 on January 13, 2006  
(Date)MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

  
(Signature of Person Mailing Correspondence)EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.

10/564997

IP15 Rec'd PCT/PTO 13 JAN 2006

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No. To Be Assigned	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
------------------------------	---------------------------------	----------------------------	----------------------------------

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this Declaration For Utility Or Design Patent Application - 3 Pages  
(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.

20231-0001 on January 13, 2006  
(Date)

MARIA T. SANCHEZ  
(Typed or Printed Name of Person Mailing Correspondence)

  
(Signature of Person Mailing Correspondence)

EV 689560067 US  
(Express Mail Mailing Label Number)

**Note: Each paper must have its own certificate of mailing.**

10/564997

IAP15 REC-UPCT/PTD 13 JAN 2006

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.  
To Be AssignedFiling Date  
January 13, 2006Examiner  
To Be AssignedGroup Art Unit  
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this Form PCT/IB/301 for PCT/JP2004/007706 - 3 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.20231-0001 on January 13, 2006  
(Date)MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

  
(Signature of Person Mailing Correspondence)EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.



10/564997

JP15 Rec'd PCT/PTO 13 JAN 2006

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahito MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.  
To Be AssignedFiling Date  
January 13, 2006Examiner  
To Be AssignedGroup Art Unit  
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this Form PCT/IB/304 for PCT/JP2004/007706 - 1 Page

(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.20231-0001 on January 13, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)



(Signature of Person Mailing Correspondence)

EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No. To Be Assigned	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
------------------------------	---------------------------------	----------------------------	----------------------------------

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this Form PCT/IB/306 for PCT/JP2004/007706 - 1 Page

*(Identify type of correspondence)*

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.

20231-0001 on January 13, 2006

*(Date)*

**MARIA T. SANCHEZ**

*(Typed or Printed Name of Person Mailing Correspondence)*



*(Signature of Person Mailing Correspondence)*

**EV 689560067 US**

*("Express Mail" Mailing Label Number)*

**Note: Each paper must have its own certificate of mailing.**

10/564997

IAP15 Rec'd PCT/PTO 13 JAN 2006

**CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)**

Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI

Docket No.

2003JP314

Serial No.

To Be Assigned

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND  
METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this Form PCT/IB/308 for PCT/JP2004/007706 - 1 Page

(Identify type of correspondence)


is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under  
37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.

20231-0001 on January 13, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)




(Signature of Person Mailing Correspondence)

EV 689560067 US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.

<b>CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)</b> Applicant(s): Tatsuro NAGAHARA, Tadahi MUTOH, Masanobu YAHASHI			Docket No. 2003JP314
Serial No. To Be Assigned	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: <b>DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM</b>			
<p>I hereby certify that this <u>WO 2005/006083 A1 - 2 Pages</u>  <i>(Identify type of correspondence)</i></p> <p>is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C.</p> <p>20231-0001 on <u>January 13, 2006</u>  <i>(Date)</i></p> <div style="text-align: right; margin-top: 20px;"> <u>MARIA T. SANCHEZ</u>  <i>(Typed or Printed Name of Person Mailing Correspondence)</i>    <i>(Signature of Person Mailing Correspondence)</i> </div> <div style="text-align: right; margin-top: 10px;"> <u>EV 689560067 US</u>  <i>("Express Mail" Mailing Label Number)</i> </div>			
<p><b>Note: Each paper must have its own certificate of mailing.</b></p>			